

UTILITY PATENT APPLICATION
UNDER 37 CFR 1.53(b)

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Washington D.C. 20231

Case Docket No. 2328-053

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Sir:

Transmitted herewith for filing is the patent application of:

INVENTOR: Tuqiang NI of Fremont, CA; Frank Y. LIN of Fremont, CA;
Chung-Ho HUANG of Fremont, CA; and Weinan JIANG of San Jose, CA
FOR: PLASMA PROCESSING METHOD AND APPARATUS WITH CONTROL OF PLASMA
EXCITATION POWER

Enclosed are:

- ☒ [X] 21 pages of specification, claims, abstract
- ☒ [X] Declaration & Power of Attorney
- ☐ [] Priority Claimed
- ☐ [] Certified copy of _____
- ☒ [X] 3 sheets of formal drawing (Figs. 1-6)
- ☒ [x] An assignment of the invention to Lam Research Corporation
and the assignment recordation fee
- ☒ [X] Return Receipt Postcard
- ☐ [] Information Disclosure Statement, Form PTO-1449
- ☐ [] Copies of IDS Citations
- ☐ []

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